

41  
Our Ref.: 3008-0034  
File No.: 521.41463X00  
Client Ref.: PHCF-01103

PATENT

2811



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Oka, et al. :  
: Art Unit: 2811  
Application S/N 09/925,626 :  
: Examiner: Shouxiang Hu  
Filed: August 10, 2001 :  
Confirmation No. 2918 :  
Customer No. 020457 :

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,  
CRYSTALLINE SILICON FILM PHOTOVOLTAIC DEVICE, AND PROCESS  
FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR  
DEVICE

**TRANSMITTAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 17, 2004

Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ No additional fee is required.  
☒ Also attached: Credit Card Payment Form

The fee (if applicable) has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	34	20	14	x \$18 =	\$252.00
Independent Claims	5	4	1	x \$86 =	\$86.00
TOTAL FEE DUE					\$338.00

Our Ref.: 3008-0034  
File No.: 521.41463X00  
Client Ref.: PHCF-01103

PATENT

- [X] A Credit Card Payment form in the amount of \$338.00 is attached
- [X] Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment, to Deposit Account No. 01-2135, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully Submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



Sterling W. Chandler  
Registration No. 51,370

Suite 1800  
1300 North Seventeenth Street  
Arlington, VA 22209  
Telephone: (703) 236-6080  
Facsimile: (703) 312-6666

SWC/slk

Our Ref.: 3008-0034  
File No.: 521.41463X00  
Client Ref.: PHCF-01103

PATENT



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
Oka, et al. :  
: Art Unit: 2811  
Application S/N 09/925,626 :  
: Examiner: Shouxiang Hu  
Filed: August 10, 2001 :  
Confirmation No. 2918 :  
Customer No. 020457 :

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,  
CRYSTALLINE SILICON FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR  
PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 17, 2004

Sir:

In response to the non-final Official Action dated December 17, 2003, the time for response to which is up to and including March 17, 2004, please amend the above-identified application as listed below and as set forth on the following pages:

**Amendments to the Claims** follow.

**Remarks** are included following the amendments.

03/18/2004 JBALINAH 00000103 09925626

01 FC:1201 86.00 OP  
02 FC:1202 252.00 OP